Attachment no. 1 to Programme of Education

Field of study educational effects for *Mechatronics* second level studies – general academic

Faculty: Microsystem Electronics and Photonics Field of study: Electronics and Telecommunication Level of studies: second level, full time study

Location of the field of study in the area (areas) of education:

Area of education:technical studiesBranch of science:technical studiesDiscipline:electronics (main discipline), mechanical engineering, information science

The graduates in the field of *Mechatronics* have interdisciplinary knowledge and skills that allow to solve specific interdisciplinary issues, i.e. electronic, programming and mechanical problems on the level of components, systems and instrumentation.

The concept of studies and their connection with the first level studies

A person applying for the second level study in the field of study *Mechatronics* should posses the first level qualifications and competences necessary for continuing education at the second level study in this field of study. The candidate should have the competences which encompass the following:

- 1. knowledge and skills in the field of mathematics, physics, metrology, production management and engineering and data recording in technique,
- 2. knowledge and skills in the field of material engineering, mechanics, construction design, driving systems, manufacturing technologies, thermodynamics,
- 3. knowledge and skills in the field of electrical engineering, electronics and optoelectronics, sensors and actuators, microprocessors and microcontrollers, control automatics, robotics and technologies in electronics,
- 4. knowledge and skills in the field of programming, programming languages, communication networks and interfaces, signal and imaging processing and computer aided engineering design,
- 5. knowledge about review and applications of mechatronics and basic skills connected with designing mechatronic systems, especially aspects connected with programming and electronics,
- 6. skills connected with interpretation, presentation and documentation of experimental results and presentation and documentation of a project-like task,
- 7. the skill of using English-language documents and literature.

Legend:

K (before line/dash) – field-of-study educational effects
W – category of knowledge
U – category skills
K (after line/dash) – category of social competences

P7U_W, P7U_U, P7U_K – Universal characteristics of levels in Polish Qualification Framework P7S_WG, P7S_WK, P7S_UW, P7S_UK, P7S_UO, P7S_UU, P7S_KK, P7S_KO, P7S_KR – Second stage characteristics of Polish Qualification Framework

For the precise definition of the reference to the definitions of the characteristics of the second stage of the Polish Qualification Framework, the following extensions were added and numbered:

P7S_WG_NT, P7S_WK_NT, P7S_UW_NT – Scope of teaching in the field of technical sciences

P7S_WG_INŻ, P7S_WK_INŻ, P7S_UW_INŻ - Qualifications covering engineering competencies

Field of study educational effects for the 2nd level studies in <i>Mechatronics</i>	DESCRIPTION OF FIELD OF STUDY EDUCATIONAL EFFECTS Upon completion of the second level study in the field of <i>Mechatronics</i> the graduate:	Correlation of educational effects with universal characteristics of PQF, with second stage characteristics of PQF for qualifications on the 7 th level, with second stage characteristics of PQF for engineering competences on the 7 th level	
KNOWLEDGE			
K2MTR_W01	K2MTR_W01 knows the principle of operation of popular digital telecommunication interfaces used in mechatronics P7U_W		
K2MTR_W02	knows the methodology of design and programming of electronic embedded systems for applications used in mechatronics	P7U_W	
K2MTR_W03	has actual knowledge about principles of operation and design methods of battery-less and wireless systems	P7U_W P7S_WG P7S_WG_NT P7S_WG_INŻ	
K2MTR_W04	has theoretically grounded general knowledge concerning designing and construction of electronic apparatus	P7U_W	
K2MTR_W05	has precise knowledge concerning construction, principles of operation and application area of microprocessors integrated circuits	P7S_WG P7S_WG_NT P7S_WG_INŻ	
K2MTR_W06	has theoretically grounded knowledge concerning material's diagnostic methods applied in electronics	P7S_WG	

K2MTR_W07	has general knowledge from the completed main courses during the studies, detailed knowledge on specific topics and knows development trends in mechatronics and other disciplines connected with mechatronics	P7S_W P7S_WG P7S_WG_NT P7S_WG_INŻ
K2MTR_W08	has completed the diploma thesis, basing on the acquired during the studies knowledge, specific for studied field of study in <i>Mechatronics</i>	P7U_W P7S_WG P7S_WG_NT P7S_WG_INŻ
K2MTR_W09	has knowledge concerning manufacturing processes and application of novel optoelectronic elements and devices in microsystems	P7S_WG
K2MTR_W10	knows the application principles of micromechanisms and microdrives in the technology and daily life	P7S_WG P7S_WG_NT P7S_WG_INŻ
K2MTR_W11	knows the construction, technology and application possibilities of micro-opto-electro mechanical systems (MOEMS) in modern technique	P7S_WG P7S_WG_NT P7S_WG_INŻ
K2MTR_W12	has theoretically grounded knowledge concerning optical fibre technique, including knowledge necessary to understand physical principles of operation of optical fibres and optical telecommunication systems	P7S_WG P7S_WG_NT P7S_WG_INŻ
K2MTR_W13	has theoretically grounded and practical knowledge concerning numerical methods and tools for electronic micro- and nanosystems modelling and designing	P7S_WG P7S_WG_NT P7S_WG_INŻ
K2MTR_W14	has knowledge concerning reliability theory in mechatronics including: methods of mechatronic systems testing and diagnostics, reliability characteristics and distributions, estimation of reliability parameters, failure models	P7S_WG P7S_WG_NT P7S_WG_INŻ
K2MTR_W15	has ordered, theoretically grounded knowledge concerning construction, principle of operation, properties and applications of chemical and optical fibre sensors used in electronics and knows development trends of advanced sensing systems	P7S_WG P7S_WG_NT P7S_WG_INŻ
K2MTR_W16	has ordered and extended knowledge concerning construction and principle of operation of analogue and digital electronic circuits and signal processing methods, i.e. from sensing system	P7U_W P7S_WG

K2MTR_W17	has ordered and theoretically grounded knowledge concerning advanced microelectronic technologies, manufacturing processes of thin and thick film electronic elements and integrated circuits and biochemical sensors, knows the actual state of the art and development trends in advanced microelectronic technologies	P7S_WG P7S_WG_NT P7S_WG_INŻ
K2MTR_W18	knows and understands the area of application and characteristics of optoelectronic systems and basic concepts concerning construction of electronic elements, especially the optoelectronic elements	P7S_WG
K2MTR_W19	has extended knowledge concerning metrology and application of devices for control and measurements; knows and understands methods of physical quantities measurements, characteristics of measured objects and remote control by virtual apparatus	P7U_W P7S_WG
K2MTR_W20	has knowledge concerning applications of laser technology for manufacturing i.e. cutting, welding, hardfacing and laser micromachining; understands the principle of laser's operation, optical energy transfer and its interaction with matter	P7U_W P7S_WG
K2MTR_W21	has knowledge concerning enterprise management, in particular projects and management of interdisciplinary teams, that implements mechatronic projects	P7S_WK P7S_WK_NT P7S_WK_INŻ
K2MTR_W22	has knowledge concerning the basic concepts of the theory and techniques of systems and operational processes management; also has the knowledge of innovative problem solving, conceptual design and rules of solution selection	P7U_W P7S_WG
K2MTR_W23	has knowledge concerning the construction and operation of the typical mechatronic systems in working machines and a variety of vehicles (hoists, storage devices, construction, mining, agriculture machines, etc.)	P7S_WG P7S_WG_NT P7S_WG_INŻ
K2MTR_W24	has knowledge of the dynamics modelling of mechatronic systems, taking into account the definition of the finite element of mechanical, electrical, electrohydraulic objects, etc.	P7S_WG
K2MTR_W25	has knowledge concerning probability theory, mathematical statistics and probability distributions, particularly related to mechatronics	P7U_W
SKILLS		
K2MTR_U01	is able to choose and configure digital communication interface, according to mechatronic project requirements	P7S_UW P7S_UW2_NT P7S_UW4_NT P7S_UW2_INŻ P7S_UW4_INŻ

K2MTR_U02	is able to design, program and construct an embedded system, which is an integral part of a mechatronic system	P7S_UW P7S_UW2_NT P7S_UW4_NT P7S_UW2_INŻ P7S_UW4_INŻ
K2MTR_U03	is able to design and program a wireless and battery-less electronic system	P7S_UW P7S_UW2_NT P7S_UW4_NT P7S_UW2_INŻ P7S_UW4_INŻ
K2MTR_U04	is able to assess and choose adequate diagnostic methods for materials and technologies applied in electronics	P7U_U P7S_UW1_NT P7S_UW2_NT P7S_UW3_NT P7S_UW1_INŻ P7S_UW2_INŻ P7S_UW3_INŻ
K2MTR_U05	is able to choose and program a microprocessor or microcontroller for application in a specialised mechatronic project	P7S_UO P7S_UW4_NT P7S_UW4_INŻ
K2MTR_U06	is able to present own research results, acquire and analyse information from the literature, databases and other correctly chosen sources; present own qualifications concerning knowledge, skills and social competences relevant to the field of study in <i>Mechatronics</i>	P7S_UW P7S_UK P7S_UU
K2MTR_U07	is able to create technical texts ("Diploma Thesis") and multimedia presentations, presenting own research results, acquire and analyse data concerning problems connected with field of study in <i>Mechatronics</i> ; critically analyse and assess current technical solutions and is able to propose new ones	P7S_UW P7S_UU P7S_UW3_NT P7S_UW3_INŻ
K2MTR_U08	is able to design and use a microsystem with optoelectronic elements and assess its functional capabilities and also can propose possible upgrades	P7S_UW3_NT P7S_UW3_INŻ
K2MTR_U09	is able to correctly choose micomachines and microdrives in practical applications	P7S_UW P7S_UW2_NT P7S_UW2_INŻ

K2MTR U10	is able to design a measurement experiment, can use correctly chosen measuring units and systems,	P7S_UW1_NT
	calculate measurement uncertainty and compile the measurements results	P7S_UW1_INŻ
K2MTR_U11		P7S_UW
	is able to correctly choose MOEMS for practical application	P7S_UW2_NT
		$\frac{P/S_UW2_INZ}{D7S_UW}$
K2MTR_U12	is able to design, start-up and test electronic analogue circuits, is able to make a cost estimation model,	P/S_UW
	knows the health and safety rules	P75_Uw2_N1 P75_UW2_NŻ
	knows and uses the workplace health and safety rules in work with lasers and optical fibres; is able to use	$\frac{175_0 \text{ w2}_\text{INZ}}{\text{P78} \text{ UW1 NT}}$
K2MTR_U13	hasic measurement devices and build a measuring system for application in optical fibre technique	P7S UW1 INŻ
	is able to use appropriate numerical methods and devices for computer aided design for electronic micro-	P7S UW2 NT
K2MTR_U14	and nanosystems design (i.e. Ansys, FlexPDE, Material Studio, etc.)	P7S UW2 INŻ
	is able to solve problems concerning reliability theory of mechatronic systems, including: calculation of	
K2MTR U15	reliability characteristics and parameters on the basis of measured data, planning methods of diagnostics	P/S_UWI_NT
_	and tests	P/S_UWI_INZ
	is able to design specific chemical and optical fibre sensor and manage concepts of its construction and	P7S_UW
K2MTR_U16	is able to design specific chemical and optical fibre sensor and prepare concepts of its construction and	P7S_UW1_NT
	parameters, is able to use appropriate constructions in designed sensing systems	P7S_UW1_INŻ
	is able to assess and compare analogue and digital circuit on the basis of its parameters and is able to	P7S LIW2 NT
K2MTR_U17	analyse its operation in different applications; is able to assess the usefulness and application possibilities	P7S UW2 INŻ
	of novel solutions concerning signal processing systems and methods	175_0 12_112
	is able to design a technological manufacturing process of a specific semiconductor or optoelectronic	P7S_UU
K2MTR_U18	devices and systems or elements manufactured in thick-film technology, is able to specify further self-	P7S_UW2_NT
	study area	P/S_UW2_INZ
	is able to choose technique and required data needed for completion of a designed project and is able to	P/S_UW
K2MTR_U19	design basic optoelectronic systems projects by self	P/S_UW3_NT
	is able to use virtual control and measuring approximation and is able to build and configure approximate	$\frac{P/S_UW3_INZ}{D7S_UW2_NT}$
K2MTR_U20	is able to use virtual control and measuring apparatus and is able to build and configure appropriate	P/S_UW2_NI D7S_UW2_INIŻ
	is able to use perspectation and investigate the operation results of a machatronic devices in different	$\frac{P/S_UW2_INZ}{D7S_UW1_NT}$
K2MTR_U21	na abie to use, parameterise and investigate the operation results of a mechatronic devices in different manufacturing technologies	Γ/S_UWI_NI P7S_UW/1_N/Ż
	is able to choose laser beam parameters for specific process, is able to use specialised equipment used in	$\frac{175_0 \text{ WI}_{\text{INZ}}}{\text{P7S} \text{ IW}1 \text{ NT}}$
K2MTR_U22	aser micromachining processes	175_0 W1_N1 P7S_UW1_NŻ
	laser meromaenning processes	175_0 W1_1NZ

K2MTR_U23	is able to analyse the construction and operation principle of various mechatronic systems applied in the working machines and vehicles, is able to design and carry out a research experiment	P7S_UW2_NT P7S_UW2_INŻ
K2MTR_U24	is able to perform computer simulation of hydraulic system's operation, analyse dynamic processes; is	P7S_UW2_NT
	able to analyse and construct a hydrotronic system	P7S_UW2_INŻ
K2MTR_U25	is able to model mechatronic system in professional virtual design programs (CAS, MBS, MES), perform	P7S_UW2_NT
	static and dynamic calculations in linear and non-linear range	P7S_UW2_INŻ
	knows foreign language at the upper-intermediate level (B2+) used in the studied field of specialisation;	
K2MTR_U26	is able to communicate in work (oral communication and writing), knows more than one foreign	P7S_UK
	language	
	understands and is able to use the basic concepts of probability theory and mathematical statistics in	P7U_U
K2MTR_U27	mechatronic practice	P7S_UW2_NT
		P7S_UW2_INZ
SOCIAL COMPETENCES		
	is able to think and act in creative and entrepreneurial way, work in a group, understands the importance	P7U_K
K2MTR_K01	and knows possibilities of constant self-study, analyses taken decision and its influence on the	P7S_KO
	environment and dilemmas related with it	P7S_KR
K2MTR_K02	is able to work by self and in a group, undertaking different roles in the group	P7U_K
K2MTR_K03	is able to co-work and work in a group, undertaking different roles in the group	P7U_K
K2MTR_K04	plans his or her actions in a creative way, is able to specify priorities and the order of tasks	P7S_KK
VOMTD VOS	understands the need to learn and use new techniques and technologies and is able to define goals and	D7S VV
K2M1K_K05	predicts the effects of the undertaken experimental work and works independently and in a team	r/s_kk
K2MTR_K06	takes into account the necessity for application of numerical methods in electronic system design	P7S_KK
K2MTR K07	is able to see the aspects connected with the reliability of mechatronic systems and statistical presentation	P7∐ K
	of the measurement data in various fields of engineering practice	170_K
K2MTR K08	understands the necessity for constant learning and understands the operation principle of the sensor	P7S KK
	systems and the necessity for their application in diagnostic and control systems	
K2MTR K09	while working in a group, properly identifies, solves and implements knowledge concerning the design	P/U_K
	and application of electronic circuits	P7S_KR
K2MTR K10	understands the influence of applied technologies on the environment and is conscious of limits that are	P/S_KO
	connected with it	P/S_KR
K2MTR_K11	development of skills connected with working in group and taking responsibility for results of own work	P'/U_K
K2MTR_K12	is able to see positive aspects of virtual control and measuring apparatus application in engineering	P7S KK
	practice	

K2MTR_K13	is conscious of importance and understands the non-technical aspects and results of mechatronic engineer work, its influence on the environment and responsibility for own decisions	P7S_KR
K2MTR_K14	is able to specify the priorities concerning the completion of a task specified by himself or others	P7S_KK P7S_KO
K2MTR_K15	is able to search and use the literature, acquire knowledge by himself, works systematically and develops skills; is able to work in a group	P7U_K